Search Notes				

Application No.	Applicant(s)
10/670,520	ASAKAWA ET AL.
Examiner	Art Unit
•	·

2813

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

EXMR

DATE

6/24/2004

6/24/2004

6/24/2004

Stephen W. Smoot

Considered all references cited in

Key Words: Porous Material - Pores, Voids, Substrate; Mask, Photomask;

Impregnate, Via, Feedthrough, Trace,

Conductor, Metal - Infiltrate,

parent application.

	SEARCHED			
Class	Subclass	Date	Examiner	
257	775	6/24/2004	sws	
257	E23.169	6/24/2004	sws	
257	E23.174	6/24/2004	SWS .] \
174	262	6/24/2004	sws) & h
200	264	6/24/2004	sws	
428	550	6/24/2004	sws	
428	566	6/24/2004	sws	
430	5	6/24/2004	sws	
430	269	6/24/2004	sws	
Updated	Above	11/9/2004	sws	\$ M. S

INTERFERENCE SEARCHED

Date

11/9/2004

Examiner

Subclass

,	Updated Above Search	1
	Search Tools - EAST (attached): USPAT; US PG PUBS; Derwent; EPO; JPO; IBM TDB	6

	Throughhole, Interconnect, Wiring.	6/24/2004
,	Updated Above Search	11/9/2004
	Search Tools - EAST (attached): USPAT; US PG PUBS; Derwent; EPO; JPO; IBM TDB	6/24/2004 8 11-9-04
•		

Same as Above

Class